

JC929 U.S. PTO
09/841187
04/25/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Michael L. Nelson *et al.*

Appl. No. (to be assigned)

Filed: Herewith

For: **Method And System For
Improving Focus Accuracy In A
Lithography System**

Confirmation No. (to be assigned)

Art Unit: (to be assigned)

Examiner: (to be assigned)

Atty. Docket: 1857.0350000

**Authorization To Treat A Reply As Incorporating An Extension Of
Time Under 37 C.F.R. § 1.136(a)(3)**

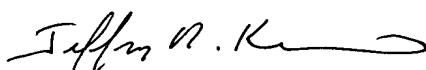
Commissioner for Patents
Washington, D.C. 20231

Sir:

The U.S. Patent and Trademark Office is hereby authorized to treat any concurrent or future reply that requires a petition for an extension of time under this paragraph for its timely submission, as incorporating a petition for extension of time for the appropriate length of time. The U.S. Patent and Trademark Office is hereby authorized to charge all required extension of time fees to our Deposit Account No. 19-0036, if such fees are not otherwise provided for in such reply. A duplicate copy of this authorization is enclosed.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.


Jeffrey R. Kurin
Attorney for Applicants
Registration No. 41,132

Date: 4/25/01

1100 New York Avenue, N.W., Suite 600
Washington, D.C. 20005-3934
(202) 371-2600

JRK/agj
076.PTO

P:\USERS\AGJONES\EGROUP\JRK\1857-035.auth
SKGF 1/26/01 mac